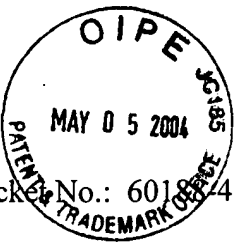


EFW

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Docket No.: 601890/413

Corres. and Mail  
**BOX AF**

AF/2823

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	<b>RESPONSE UNDER 37 CFR 1.116</b>
	:	<b><u>EXPEDITED PROCEDURE</u></b>
Gaku SUGAHARA, et al.	:	
	:	Customer Number: 20277
Serial No.: 09/890,095	:	
	:	Confirmation Number: 6059
	:	
	:	Group Art Unit: 2828
Filed: July 27, 2001	:	
	:	Examiner: Dung T. Nguyen

For: SEMICONDUCTOR LASER DEVICE, METHOD FOR FABRICATING THE  
SAME, AND OPTICAL DISK APPARATUS

**REQUEST FOR RECONSIDERATION**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action dated February 24, 2004, having a shortened statutory period for response set to expire May 24, 2004, reconsideration of the above-identified application is respectfully requested in view of the following remarks.